



Docket No.: M4065.0210/P210-A

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Sam Yang et al.

Application No.: 10/002,176

Confirmation No.: 3795

Filed: December 5, 2001

Art Unit: 2814

For: METHOD OF FORMING A CAPACITOR
FOR A SEMICONDUCTOR DEVICE

Examiner: H. B. Trinh

Enter
Examiner
5/16/06

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated February 28, 2006, finally rejecting claims 32-55, 57-65, 68, 97 and 98, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.